

L Numb er	Hits	Search Text	DB	Time stamp
-	7119	<b>thin with film with filter</b>	USPAT; EPO; JPO; DERWENT	2003/03/25 11:09
-	23626	<b>indium with tin with oxide</b>	USPAT; EPO; JPO; DERWENT	2003/03/25 11:13
-	7365	<b>WDM</b>	USPAT; EPO; JPO; DERWENT	2003/03/25 11:12
-	3	<b>(thin with film with filter) and (indium with tin with oxide) and WDM</b>	USPAT; EPO; JPO; DERWENT	2003/03/25 13:13
-	3298	<b>(indium with tin with oxide) with (compris\$3 or composition)</b>	USPAT; EPO; JPO; DERWENT	2003/03/25 11:16
-	6	<b>((indium with tin with oxide) with (compris\$3 or composition)) and WDM</b>	USPAT; US-PGPUB; DERWENT	2003/03/25 11:14
-	4	<b>((indium with tin with oxide) with (compris\$3 or composition)) and WDM) not ((thin with film with filter) and (indium with tin with oxide) and WDM)</b>	USPAT; US-PGPUB; DERWENT	2003/03/25 11:15
-	124	<b>(indium with tin with oxide) with ((compris\$3 or composition) and "%")</b>	USPAT; EPO; JPO; DERWENT	2003/03/25 11:19
-	84	<b>(indium with tin with oxide) with ((compris\$3 or composition) and percent)</b>	USPAT; EPO; JPO; DERWENT	2003/03/25 11:18
-	0	<b>(indium with tin with oxide) with ((compris\$3 or composition) and ((tin or indium) near 3percent))</b>	USPAT; EPO; JPO; DERWENT	2003/03/25 11:19
-	55	<b>(indium with tin with oxide) with ((compris\$3 or composition) and ((tin or indium) near3 "%"))</b>	USPAT; EPO; JPO; DERWENT	2003/03/25 11:19
-	5576	<b>wavelength with division with multiplexing</b>	USPAT; EPO; JPO; DERWENT	2003/03/25 13:49
-	3	<b>(thin with film with filter) and (indium with tin with oxide) and (wavelength with division with multiplexing)</b>	USPAT; EPO; JPO; DERWENT	2003/03/25 13:15
-	579015	<b>cavit\$3</b>	USPAT; EPO; JPO; DERWENT	2003/03/25 13:15
-	173	<b>(wavelength with division with multiplexing) same cavit\$3</b>	USPAT; EPO; JPO; DERWENT	2003/03/25 13:15
-	0	<b>((wavelength with division with multiplexing) same cavit\$3) and (thin with film with filter) and (indium with tin with oxide)</b>	USPAT; EPO; JPO; DERWENT	2003/03/25 13:15

-	7	((wavelength with division with multiplexing) same cavity\$3) and (indium with tin with oxide) 6215592.pn.	USPAT; EPO; JPO; DERWENT	2003/03/25 13:33
-	2		USPAT; EPO; JPO; DERWENT	2003/03/25 13:33
-	260647	(silicon or aluminum) with oxide	USPAT; EPO; JPO; DERWENT	2003/03/25 13:50
-	19	(indium with tin with oxide) and (wavelength with division with multiplexing) and ((silicon or aluminum) with oxide)	USPAT; EPO; JPO; DERWENT	2003/03/25 13:50